

IN THE CLAIMS

Please rewrite claims 1 and 7 as follows:

Sub
B1 C1
1. (Twice Amended) A method for forming a first-property semiconductor film at a desired position on a substrate, comprising the steps of:

- a) preparing the substrate having a second-property semiconductor film formed thereon;
- b) preparing an optical mask having a predetermined pattern on another substrate which is apart from the substrate;
- c) relatively positioning a projection area of the optical mask at the desired position on the substrate;
- d) irradiating the desired position of the second-property semiconductor film with laser light through the optical mask to change an irradiated portion of the second-property semiconductor film to the first-property semiconductor film; and
- e) forming an insulation film on the first-property semiconductor film and the second-property semiconductor film.

B2
Sub
C2
7. (Twice Amended) A method for forming a crystalline semiconductor film at a desired position on a substrate, comprising the steps of:

- a) preparing the substrate having an amorphous semiconductor film formed thereon;
- b) preparing an optical mask having a predetermined pattern on another substrate which is apart from the substrate;
- c) relatively positioning a projection area of the optical mask at the desired position on the substrate;

- d) irradiating the desired position of the amorphous semiconductor film with laser light through the optical mask to change an irradiated portion of the amorphous semiconductor film to the crystalline semiconductor film; and
 - e) forming an insulation film on the crystalline semiconductor film and the amorphous semiconductor film.
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REMARKS

The Applicant filed Information Disclosure Statements (IDS) on October 15, 2001, April 9, 2001, and October 27, 2000. Copies of Form PTO-1449 (1449) for each IDS were attached to the Office Action mailed on October 31, 2001, but these were not properly acknowledged as considered by the Examiner. Specifically, the Form PTO-1449 for the IDS filed on October 15, 2001, was signed and dated, but the reference was not initialed. The Form PTO-1449 for the IDS filed on April 9, 2001 had each reference initialed, but the Examiner neither signed nor dated it. Likewise, the Form PTO-1449 for the IDS filed on October 27, 2000 had the reference initialed, but the Examiner did not sign or date it. It is respectfully requested that copies of complete 1449's for each of the IDS's mentioned above be forwarded with the next Office Action.

Claims 1-4 were rejected under 35 U.S.C. §102(e) as being anticipated by Makita et al., U.S. Patent No. 5,821,562. Claims 5-10 were rejected under 35 U.S.C. §103(a) as being unpatentable over Makita et al., in view of Yamazaki et al., U.S. Patent No. 5,886,366.